INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

March 25, 2026

IGI Report Number	LG785604573
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.32 - 9.34 X 5.61 MM

GRADING RESULTS

Carat Weight	3.03 CARATS
Color Grade	D
Clarity Grade	VVS 1
Cut Grade	EXCELLENT

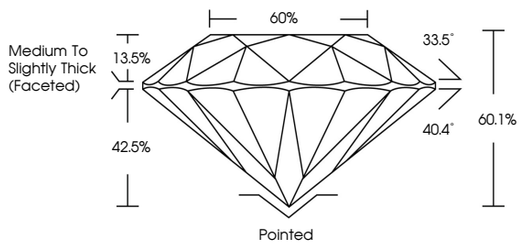
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG785604573

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG785604573
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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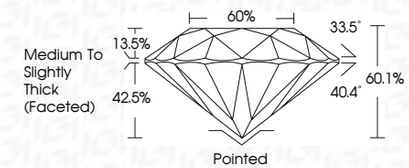

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IGI

March 25, 2026
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ROUND BRILLIANT
9.32 - 9.34 X 5.61 MM
Carat Weight 3.03 CARATS
Color Grade D
Clarity Grade VVS 1
Cut Grade EXCELLENT
Depth 60.1%
Table 60%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG785604573
Comments:
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Type IIa